Spatially nonuniform energy distribution of electrons in a submicron semiconductor

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The sym metric part of the distribution of the electrons in a sem iconductor submicron lm, placed between a heater and refrigeration unit, is derived and analyzed. It is shown that, in general, it is of non-Ferm i (non-Maxwellian) nature. A new mechanism is proposed to account for the non-Maxwellian form of the sym metric part of the distribution function. This mechanism is based on the dierent energy dependences of the momentum relaxation time in the bulk of the sem iconductor and its skin layer.

In recent years we have witnessed an increase in the number of problems in which transport phenomena occur under conditions such that the ux of charge carriers moves along an inhomogeneity of the symmetric part of the energy distribution function, which is caused by a departure of carriers from equilibrium (due to an external stimulus).

When the symmetric part of the nonequilibrium distribution function of carriers is of the Fermi (Maxwellian) type, the problem can be solved relatively simply (see, for example, Refs. 146) by the use of elective boundary conditions.

However, there are frequency cases in which for a variety of reasons the symmetric part of the equilibrium distribution function is not of the Ferm i type.  $^{8}$  {10 In this case, if the external stimulus is an externally in posed potential dierence, the physical phenomena are generally insensitive to the actual form of the symmetric part of the distribution functional 11 (the few exceptions 12;13 con method general rule). The situation is dierent if the electron ux is caused by the presence of a refrigerator or a heater. We recall that in the temperature approximation (in which the symmetric part of the distribution function is Maxwellian) the role of the external force is played by a temperature gradient. It is necessary in this case to single out the contribution due to a gradient of the chemical potential (Refs. 14 and 15), i.e., by dividing the thermal diusion ux into a ux which is due to the built—in thermoelectric eld ( r ) and which is compensated by the drift ux ( r', where ' is the electrical potential) and a thermal diusion ux which is included in the external circuit and which forms the thermoelectric current.

However, if the symmetric part of the distribution function is not of the Fermi (Maxwellian) type, the absence of the concepts of temperature gradient and them ical potential gradient (the concepts of temperature and them ical potential in general) creates the problem of separation of the thermaldiusion ux. A coordingly, in the absence of temperature and of them ical potential it is necessary to reformulate the problem of calculation of the thermoelectric current and the thermoelectric emf.

It is shown in Ref. 15 that a correct calculation of an emf of any nature requires consideration of closed circuits, i.e., a study of the physical phenomena which give rise to an emf in the presence of a transport current.

This problem will be dealt with in a separate communication. Our aim here is to prove the hypothesis that a sem iconductor lm whose thickness is less than the characteristic energy relaxation length (which corresponds to submicron thicknesses) which is placed between a heater and a refrigerator, and which is short-circuited to an external resistance generally forms a distribution function of carriers whose symmetric part is not of the Fermi (Maxwellian) type. We shall show below that there is a fundamentally new mechanism for the formation of the symmetric part of the distribution function which is related entirely to the closed nature of the circuit. This mechanism is responsible for the function  $f_0$  (";r), which diers substantially from the Fermi function. Therefore, one of the goals of the present paper is to identify a case in which such a problem is encountered. Such a problem is encountered in a submicron-thick therm oelement which is connected to an external circuit.

It is shown in Ref. 10 and 13 that in a submicron Importance in gnore the bulk process of energy relaxation. The electron-electron collisions is then governed by the ratio of two frequencies: the frequency of the electron-electron collisions and the surface energy relaxation frequency. Since in the case of submicron layers the latter exceeds greatly the energy relaxation frequency, the electron-electron collisions are generally ine ective. Therefore, in ixing of the electron uxes with a xed energy (partial current) disappears in the bulk and the macroscopic characteristics should then depend strongly on the actual shape of the symmetric part of the distribution function. This means that in such a closed therm collectric circuit the symmetric part of the electron distribution function cannot, for fundamental reasons, be approximated by a Maxwellian function with an elective temperature (which is frequently done in the case of bulk samples of the symmetric part of the electron distribution in the case of bulk samples of the symmetric part of the electron distribution function cannot, for fundamental reasons, be approximated by a Maxwellian function with an elective temperature (which is frequently done in the case of bulk samples of the symmetric part of the electron distribution function in the case of bulk samples of the symmetric part of the electron distribution function cannot for fundamental reasons, be approximated by a Maxwellian function with an elective temperature (which is frequently done in the case of bulk samples of the symmetric part of the symmetric part of the electron distribution function with an elective temperature (which is frequently done in the case of bulk samples of the symmetric part of the symmetric part of the electron distribution function with an electron distribution function with a first part of the electron distribution function with a first part of the electron d

We shall consider a conducting sem iconductor  $\mbox{lm}$  of subm icron thickness 2a, whose one surface at x=a is in contact with a heater held at a temperature  $T_1$  and the other surface at x=+a is in contact with a refrigerator held at  $T_2$ . A therm coelectric current can ow along the x axis when the contacts are closed. For simplicity, we shall consider only the case in which  $T_1$   $T_2$   $T_1$ ;  $T_2$  and then in the rst approximation with respect to  $T_1$   $T_2$   $T_3$ .

[where  $T = (T_1 + T_2)=2$ ] we not that the distribution function is described by the following system of equations:

$$\frac{p}{3m} \frac{\text{@}f_1(";x)}{\text{@}x} = 0;$$

$$\frac{1}{(";x)} f_1(";x) = \frac{p}{m} \frac{\text{@}f_0(";x)}{\text{@}x} + \text{eE}(x) \frac{f_0(";x)}{\text{@}"} :$$
(1)

Here e, m, and p are the charge, m ass, and electron m om entum; (";x) is the m om entum relaxation time; E(x) is the electric eld intensity; and " and x are the energy and coordinate of the current carriers.

In the derivation of the system (1) it is assumed that the electron gas is nondegenerate, that the collisions of electrons with the scattering centers are quasielastic, and that the volume collision integrals, which represent the energy relaxation in a submicron lm, are unimportant. We can then write the electron distribution function f (p;r;t) in the form

$$f(p;r;t) = f_0(";r) + f_1(";r)\frac{p}{p};$$
 (2)

where  $f_0$  (";r) and  $f_1$  (";r) (p=p) are, respectively, the symmetric part and the anisotropic part of the distribution function such that  $jf_1j = f_0$ .

We can easily see that the eld E(x) which is contained in Eq.(1) is independent of x if 1. In the approximation linear in , the system (1) then reduces to

$$\frac{\partial^2 f_0(";x)}{\partial x^2} = 0:$$
 (3)

The distribution function  $f_0$  (";x) in this case can easily be sought in the form

$$f_0(";x) = \exp \frac{"}{T} [1 + (";x)];$$
 (4)

where is the chemical potential of electrons at a temperature T. The normalization condition then gives

$$z_1$$
 $d''g('') ('';x) \exp \frac{u}{T}$ 
(5)

Substituting Eq. (4) into Eq. (3), we not the following expression for (";x):

$$(";x) = C_1(";x) [x + C_2(")];$$
 (6)

The functions  $C_1$  (") and  $C_2$  (") represent the boundary conditions at the x = a surfaces.

We shall now form ulate these boundary conditions. A susual (see Ref. 7), we assume that between the sem iconductor and the constant-tem perature chamber (for example, in the x=a plane) there is a transition layer of thickness 2, under the assumption that the function  $f_0$  (";x) is continuous at the points x=a+.

The existence of surface energy relaxation mechanisms mentioned above corresponds to the case in which the strength equation in system (1), which describes the distribution function in a transition layer, contains collision integrals representing energy transfer from electrons in a given particle ux to the constant-tem perature system whose tem perature is  $T_2$ . The absence of such collision integrals in the case of the submicron  $\,$  Im and their presence in the transition layer should not be regarded as surprising, since only a peculiar behavior of these integrals (in the lim it ! 0) can give rise to a nonzero surface energy relaxation rate. C learly, inclusion of these collision integrals corresponds to \m ixing" of the partial uxes, which facilitates the formation of a Maxwellian distribution  $f_0$  (";x) in the sem iconductor near surface. In addition to this interaction of electrons with the constant-temperature system during the ow of a current, there is another mechanism for the energy exchange between the electron gas in the lm and the constant-tem perature chamber (which is e ected by the current itself. Since we are interested in the case where  $f_0$  (";x) resembles the M axwellian shape as little as possible, we assume that in the case of the transition layer (and the submicron lm) there are no collision integrals<sup>20</sup> in the rst equation in system (1). It is important to stress that the mechanism for the energy transfer, which is associated with the ow of a current, operates even when the total current j is zero. In fact, it does not follow from j = 0 that the partial current j(";x) vanishes. The partial currents therefore e ect the energy exchange between the electron gas in the Im and the constant-tem perature chamber, even when the circuit is open.

Under the assumptions made above it follows from system (1) that

$$j(";x = a) = j(";x = a+)$$
 (7)

where the partial current j(";x) is given by the expressions<sup>7</sup>

$$j(";x) = \frac{2e}{3m} "g(") (") \frac{\partial f_0}{\partial x} + eE \frac{\partial f_0}{\partial "} :$$
 (8)

Here g(") is the density of electron states. The total current density j is de ned in term s of j(";x) as follows:

$$j = \int_{0}^{Z_{1}} d'' j('';x):$$
 (9)

Substituting in j (";x = a + ) the parameters of the transition layer, replacing the derivative  $@f_{0s}=@x$  ( $f_{0s}$  is the symmetric part of the distribution function in the transition layer) by  $[f_0$  (";x = a + )  $f_0$  (";x = a - )]=, and assuming that approaches zero, we note from Eq. (8) the following expression (such a procedure is described in greater detail in Ref. 7):

$$j(";x = a) = \frac{s(")}{s}j \quad s(") \exp \frac{"}{T} \exp \frac{(T_2)}{T_2} = f_0(";x = a) + \frac{s(")}{s} \int_0^T d" s(") \exp \frac{(T_2)}{T_2} = \exp \frac{(T_2)}{T_2} = f_0(";x = a) + f_0$$

H ere

$$_{s}(") = \lim_{t \to 0} \frac{2e^{2} "g_{s}(")_{s}(") \exp \frac{-(T) - "}{T}}{3m T};$$
 (11)

$$_{s}(") = \lim_{\stackrel{!}{=} 0} \frac{2eg_{s}(")_{s}(") exp_{s}(")_{s}(")}{3m};$$
 (12)

and

$$z_{1}$$

$$s = d'' s('')$$
(13)

are the param eters of the transition layer, and  $g_s$  (") and  $g_s$  (") are the density of the electron states and the relaxation time in a transition layer.

Substituting in Eq. (10) (and in a relation similar to it, at x = d) the function  $f_0$  (";x) in the form (4) and (6), we nd, in a linear approximation in

$$\frac{\text{(")}}{\text{j}_{0}} \text{ (")} C_{1} \text{ (")} + \frac{\text{(")}}{\text{ (")}} \frac{Z_{1}}{\text{ o}} \text{ d" (")} C_{1} \text{ (")} = \frac{s \text{ (")}}{s} \text{ j}_{0} \quad s \text{ (")} \quad C_{1} \text{ (")} \text{ a} \quad C_{2} \text{ (")} + \frac{3}{4} \frac{s \text{ (")}}{2T} + \frac{s \text{ (")}}{s} \frac{Z_{1}}{\text{ o}} \text{ d"} \quad s \text{ (")}$$

$$C_{1} \text{ (")} \text{ a} \quad C_{2} + \frac{3}{4} \frac{\text{ "}}{2T} \text{ ; (14)}$$

$$(") = \frac{2e^{2} "g(") (") \exp \left(\frac{T}{T}\right)"}{3m T};$$
(15)

$$(") = \frac{2e"g(") (") exp^{\frac{h}{T}} i}{3m};$$
 (16)

$$= \int_{0}^{Z_{1}} d^{n} ("); \quad j_{0} = \frac{j}{a}:$$
 (17)

For sim plicity we assume that the functions  $_s$  (") and  $_s$  (") dier by a constant [as in the case of the functions (") and (")]. From Eq. (14) we can then easily determ ine  $C_1$  (") and  $C_2$  ("):

$$C_2(") = C_2^{(0)} = const;$$
 (18)

$$C_1$$
 (") =  $\frac{s}{s}$  (")  $\frac{3}{4}$   $\frac{s}{2T}$  +  $C_1^{(0)}$   $\frac{s}{s}$  (") +  $a_s$  (") +

$$C_1^{(1)} = \frac{s(")}{("+a_s("))} + \frac{s(")}{s[("+a_s("))]} \dot{j}_0;$$
 (19)

w here

$$C_{1}^{(0)} = \frac{1}{2} \int_{0}^{Z_{1}} d\mathbf{''} (\mathbf{''})C_{1}(\mathbf{''});$$

$$C_{1}^{(1)} = \frac{1}{2} \int_{0}^{Z_{1}} d\mathbf{''} a_{s}(\mathbf{''})C_{1}(\mathbf{''}) + \frac{1}{2T} \int_{0}^{Z_{1}} d\mathbf{''}_{s}(\mathbf{''}) = \frac{3}{4} \int_{0}^{Z_{1}} d\mathbf{''}_{s}(\mathbf{''}) :$$
(20)

Since  $C_2^{(0)}$  does not depend on energy, we not from Eq. (refeq.: glt93:int) that  $C_2^{(0)} = 0$ .

The constants  $C_1^{(0)}$  and  $C_1^{(1)}$  can be easily found from system (20) by substituting  $C_1$  (").

Since in the tem perature approximation we have  $f_0(";x) = \exp[([T(x)] ")] = T(x)]$ , and since

$$T(x) = T = a\frac{T}{2a}x;$$
 (21)

it follows that in the case 1 the expression for C  $_1$  (") is

$$C_1(") = \frac{3}{4a} = \frac{"}{2aT};$$
 (22)

We can now see that the rst term in Eq. (22) represents the in uence of the heater and cooler on the distribution function when their coupling to the electron gas in the submicron Imis due to some of the partial currents induced by the builtin therm collectric eld and by thermaldiusion. The second and third terms are due to the drift components of the partial therm collectric current in the semiconductor and in the transition layer (compare with Ref. 14). Finally, the last term is due to the specience echanism for the establishment of the distribution function which we shall now consider.

For sim plicity we shall consider a contact between two n-type sem iconductors with zero contact potential, with the same electron densities, but with dierent energy dependences of the relaxation times. If we ignore the electron electron collisions and the collisions with the scattering centers accompanied by energy transfer, we not that the partial current in the presence of an external voltage, which induces a current of density j, is described by

$$div j(";x) = 0:$$
 (23)

Using Eq. (8) and (15), we obtain the following expression from Eq. (23):

$$_{1}$$
 (")E  $_{1} = _{2}$  (")E  $_{2}$  (24)

where the index 1 refers the left-hand sem iconductor and the index 2 to the right-hand sem iconductor. The electron elds  $E_1$  and  $E_2$ , which are contained in Eq. (24), can easily be expressed in terms of the total density of the current owing through the contact:

$$E_{1;2} = j = 1;2$$
: (25)

Using Eq. (25), we can write Eq. (24) in the form

$$\frac{1}{1} \frac{(")}{2} = 0; (26)$$

The last equality for dierent dependences of  $_1$  and  $_2$  on " can be valid only if the distribution functions of the two sem iconductors are non-M axwellian.

A similar situation occurs also in the absence of a contact if depends not only on the carrier energy, but also on the coordinates [naturally, if  $(";x) \in F_1(")F_2(")$  and, consequently, the coordinate dependence of the relaxation time determines the energy dependence of the distribution function.

It therefore follows that if the relaxation time in the submicron Im depends in dierent ways on the carrier energy at dierent points in the direction of ow of the current, a new mechanism, which is responsible for a basically non-Maxwellian distribution function, will appear.

Turning back to the last term in Eq. (19), we can say that it describes this species mechanism, and that the coordinate dependence of the relaxation times is related to the dierent forms of (") in the submicron layer [ (")] and at the contact

If the condition a  $_{\rm s}$  (") (") is valid for all energies ", it follows from Eq. (19) that

$$C_1(") = C_1^{(0)} \frac{e}{T} + \frac{s(")}{s(")} j_0$$
 (27)

We then see from the K irchho law that  $j_0 = 0$ , and from system (20) we not that  $C_1$  (") = 0. Therefore, (";x) = 0. It is thus clear that if  $a_s$  (") (") then the sym metric part of the distribution function of electrons in a submicron lm is M axwellian with a temperature equal to T. Such a situation can therefore be called adiabatic.

If, on the other hand, at all values of " we have a  $_{\rm s}$  (") ("), then

$$C_1(") = \frac{3}{4a} \frac{"}{2aT} + C_1^{(1)} \frac{s(")}{a_s(")} + \frac{s(")}{a_{ss}(")} j_0$$
: (28)

Since the case  $a_s(")$  (") has been reduced to the adiabatic case (thermal insulation of a lm from the beater and cooler), the case  $a_s(")$  (") can be naturally called isothermal (representing the ideal thermal coupling between electrons in the submicron lm with the heater and cooler). However, it then follows from Eq. (28) that the symmetric part of the distribution function of electrons is very far from Maxwellian. In the isothermal case the distribution function becomes Maxwellian only if the load resistance approaches in nity and the current japproaches correspondingly zero. In fact, if j=0, it follows from Eq. (28), with allowance for Eq. (20), that  $C_1(")=(3-4a)$  ("=2al), which - as pointed out above - corresponds to a Maxwellian function which depends on the coordinates in accordance with the law (21).

The maximum deviation of  $f_0$  (";x) from the Maxwellian function occurs, as demonstrated by Eq. (19), when a  $_{\rm S}$  (") and then the energy dependences represented by the two functions should be very dierent. It should be pointed out that since a is an independent parameter, a change in the thickness of the semiconductor  $\,$  Im may alter the relationships between a  $_{\rm S}$  (") and ("), which in turn may modify the symmetric part of the distribution function.

We have thus shown that the symmetric part of the distribution function of electrons in a submicron Implaced between a heater and a coolermay be far from Maxwellian. Therefore, in calculations of the thermoelectric emf and of the thermoelectric current it is necessary to formulate a new approach which does not rely on such concepts as temperature and chemical potential. Such an approach will be developed in a separate paper.

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